NANOCAVITY BASED OPTICAL PRESSURE SENSOR

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Abstract-In this paper, we design and simulation photonic crystal (Phc) Nano pressure sensor. The sensor is made of two dimensional photonic crystal and consists of hexagonal lattice structure. Photonic crystal structure uses an line defect engineering to create an waveguide. The Nano cavity is formed by changing the radius of a single rod in air structure, which is at the centre of lattice. This sensor supports 1450-1550nm wavelength. Simulation results show that resonant frequency of Nano cavity changed with the increased pressure.

Key words:photonic crystal; waveguide; Nano cavity; pressure sensor, Nano-pressure.

1 INTRODUCTION

Photonic crystals are periodic microstructure or nano structure affected by the propagation of photon. Based on the geometry of the structure photonic crystal can be classified into one dimensional (1D) two dimensional (2D), three dimensional (3D) structure [4]. PhC have photonic band gap (PBG) manipulates beam of light. Photon travels in these structures with a different wavelength. For the design 2D photonic crystal is used in 2D crystal the permittivity is changed in two directions. Defects can be done either by changing the dimension or removal from the structure and acts as a resonant cavity. Defects modify and control the flow of light inside the photonic crystal [8].

An example of application of photonic crystals is bio sensors, mechanical parameter sensor like pressure, nano displacement, structural health monitoring, chemical sensors and acoustic sensors.

In this paper, we modulate and simulate a Nano pressure sensor with two dimensional photonic crystal Nano cavity resonators. The finite difference time domain (FDTD) method is used to simulate sensor operation for different pressure. When the pressure is applied stress is distributed over the crystal structure and the refractive index is changed.

The pressure can be calculated using $P = A\omega\rho 0C$

P= acoustic pressure

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A=displacement amplitude $\omega = 2\pi f$ $\rho \theta$ = specific density of medium C= speed of sound under water Thus pressure is proportional to displacement.

2 DESIGN

In this paper uses the two dimensional photonic crystal. First design a hexagonal lattice structure. Line defect engineering isintroducedby removing the rods in hair structure. To create a resonant cavityplace a singlerod in the middle of the lattice with an increased radius and place the neighbouring coordinates with another radius. Introduce the lightsource in one end of the wave guide and light is obtained at the detector.

When the pressure is zero, displacement is also zero. The pressure applied on the resonant cavity the propagation of light through the hexagonal lattice and and refractive index also changed.

MEEP is the tool used for design and simulation of a photonic crystal. MEEP stands for MIT electromagnetic equation propagation. It is used in solving of Maxwell's equations in periodic dielectric structure simulation in 1D, 2D, 3D and cylindrical coordinates can be done. The transmitter flux can be obtained at each frequency (ω). This is the integrals of the pointing vector over a plane of the photonic crustal structure [14].

 $p(\boldsymbol{\omega}) = Re \ n \int E \boldsymbol{\omega}(X) * H \boldsymbol{\omega}(X)$

The time domain applications of MEEP consist of transmission and reflection spectra, resonant mode& frequencies and field patterns. The finite-difference time-domain (FDTD) method is used to simulate operation of sensors in different pressures.

MEEP is the tool where we design and simulation of the photonic crystal and parameters are given below. 1) Rods in air configuration

2) Hexagonal lattice structure



- 3) Lattice constant 'a' = 1nm
- 4) Radius of the rod 'r' = 0.19nm
- 5) Height of the slab is infinity



Fig-1: Layout of PhC structure consists of hexagonal lattice



Fig 2: The layout of sensor structure consists of line defect waveguide directed couple to Nano cavity.

waveguide directly connected to the Nanocavity. The light enters from the left of waveguide. A photo detector in the end of waveguide detects the light.

When the pressure is applied on the dielectric slab displacement takes place so that the nature of the electromagnetic waves is altered.

3 SIMULATION RESULTS

When the pressure is applied on the dielectric slab displacement takes place so that the nature of the electromagnetic waves is altered. Below figure shows the output spectrum for 1nm, 2nm, 3nm, 4nm, 5nm, 6nm, 7nm, 8nm, 9nm, 10nm, displacement. By analysing the curve, the width of resonant peak in cavity is different. Fig.14 shows a linear relationship between applied pressure and resonant frequency.



Fig 3: Transmission spectrum for 1 Nano displacement



Fig 4: Transmission spectrum for 2 Nano displacements



Fig 5: Transmission spectrum for 3 Nano displacement





Fig 6: Transmission spectrum for 4 Nano displacement



Fig 7: Transmission spectrum for 5 Nano displacement



Transmission spectrum for 6 Nano displacement



Fig 9: Transmission spectrum for 7 Nano displacement



Fig 10: Transmission spectrum for 8 Nano displacement



Fig 11: Transmission spectrum for 9 Nano displacement







Fig 13:Shift in frequency for 1to10nm displacement



Fig 14: The linear relationship between resonant frequency and displacement in the range of 1 to10nm displacement



Fig 15: Shift in frequency for 10 Nano displacements

4 CONCLUSION

In this paper, we have proposed a photonic crystal pressure sensor for Nano pressure measuring. This sensor is constructed with two dimensional photonic crystal waveguide which is connected to Nano cavity resonator. The sensor sensitivity is increased by applied pressure. The refractive index changes when the resonant wavelength of Nano cavity shifts. This sensor can detect small to large amount of pressure.

This paper measures accurate sensitivity of mechanical pressure sensors in terms zero to ten Nano displacement units. These sensors measure other mechanical parameters due to its versatile nature .due to pressure applied shift in frequency and wavelength are obtained. This frequency can be mapped by shift in displacement by using pressure formula. These sensors can be used in applications requiring high accurate sensing results.

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